



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): A. Smith et al.

Serial No.: 10/775,718

Filed: February 9, 2004

Cust. No.: 33123

For: **METHOD AND APPARATUS FOR  
SELF-REFERENCED WAFER  
STAGE POSITIONAL ERROR  
MAPPING**

CERTIFICATE OF MAILING  
PURSUANT TO 37 CFR 1.8

I hereby certify that this correspondence and the attached papers are being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated below in an envelope addressed to:

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450, on

3/17/05  
Date

*Michelle M. Dendy*  
Signature

**RESPONSE TO OFFICE ACTION AND REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 17, 2004 in connection with the above-identified application, Applicant requests entry of this response and reconsideration of the application.

There are no amendments to an existing claim, cancellation of an existing claim, or addition of a new claim made in this document, hence, in accordance with 37 CFR 1.121 (c) there is no listing of claims.

Remarks begin on Page 2 of this document

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